

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

November 16, 2024	
IGI Report Number	LG665421539
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	13.33 X 6.70 X 4.21 MM

GRADING RESULTS

Carat Weight	2.18 CARATS
Color Grade	F
Clarity Grade	VVS 2

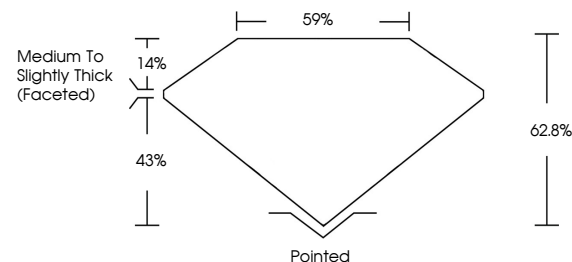
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG665421539

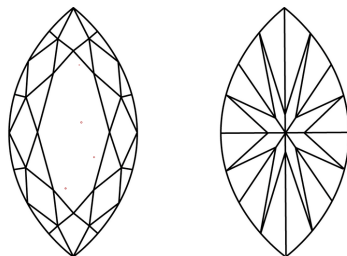
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG665421539
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

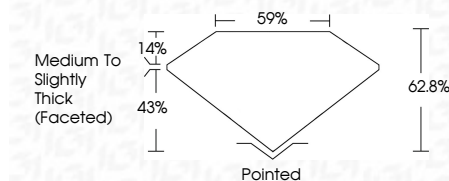
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Fluorescence	NONE
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Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



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November 14, 2024	2.18 CARATS	
GI Report No LG565421539	F	
MARKLEUSE BRILLIANT		
13.33 X 6.70 X 4.21 MM	VVS 2	62.5%
		Medium to Slightly Thick (Faceted)
		Pointed
		EXCELLENT
		EXCELLENT
		NONE
		1891 LG565421539

Comments: This is a Very Rare Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa